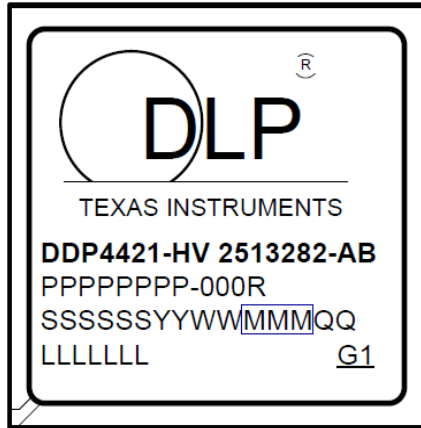


PCN Number:	20181210001		PCN Date:	12/18/2018	
Title:	DLP Controller (ASIC) BUMP Site change				
Customer Contact:	Dlp-pcn-team@list.ti.com	Dept:	DLP CQE		
Proposed 1st Ship Date:	no earlier than 04/01/2019	Estimated Sample Availability:	12/18/2018		
Change Type:					
<input type="checkbox"/>	Assembly Site	<input type="checkbox"/>	Design	<input checked="" type="checkbox"/>	Wafer Bump Site
<input type="checkbox"/>	Assembly Process	<input type="checkbox"/>	Data Sheet	<input checked="" type="checkbox"/>	Wafer Bump Material
<input type="checkbox"/>	Assembly Materials	<input type="checkbox"/>	Part number change	<input checked="" type="checkbox"/>	Wafer Bump Process
<input type="checkbox"/>	Mechanical Specification	<input type="checkbox"/>	Test Site	<input type="checkbox"/>	Wafer Fab Site
<input type="checkbox"/>	Packing/Shipping/Labeling	<input type="checkbox"/>	Test Process	<input type="checkbox"/>	Wafer Fab Materials
				<input type="checkbox"/>	Wafer Fab Process
PCN Details					
Description of Change:					
An alternate BUMP/RDL site has been qualified for the devices listed in 'Product Affected' section below.					
	Current Location	New Location			
BUMP/RDL Location	Sony, Oita	Amkor K5, South Korea			
Amkor's standard material and process will be applied for new Bump/RDL products with bump material changing from Sn/Cu to Sn/Ag.					
Material from new site is expected to ship no earlier than April 1 st , 2019. After April 1 st , 2019, customers may receive devices from either location.					
Reason for Change:					
Continuity of supply					
Anticipated impact on Form, Fit, Function, Quality or Reliability (positive / negative):					
None					
Anticipated impact on Material Declaration					
<input type="checkbox"/>	No Impact to the Material Declaration	<input checked="" type="checkbox"/>	Material Declarations or Product Content reports are driven from production data and will be available following the production release. Upon production release the revised reports can be obtained from the TI Eco-Info website . There is no impact to the material meeting current regulatory compliance requirements with this PCN change.		

Changes to product identification resulting from this PCN:

Manufacturing site code on the device marking will be updated to distinguish material from two locations



MMM: Manufacturing Site

Example manufacturing site code changes:

Device	Current Marking	New Marking
DDP442x (ASE Assembly)	HAL	HCL
DDP442x (J-Devices Assembly)	HBL	HDL
DDP442x-HV	HAL	HBL

Product Affected:

Device	Orderable P/N
DDP4421	2511897-0001
DDP4422	2511898-0001
DDP4421-HV	2513282-0001
DDP4422-HV	2513283-0001
DDP5423	2512621-0001
DLPC900	DLPC900ZPC
DLPC6421	DLPC6421ZPC

Qualification Data

This qualification has been developed for the validation of this change. The qualification data validates that the proposed change meets the applicable released technical specifications.

Qual Vehicle: DDP4421 (ASE Assembly), DDP4421(J-Devices Assembly) and DDP4421-HV

Qualification: Plan Test Results

Test	Conditions	Sample Size	Results
Precondition	30°C/70% RH/216hrs, 255°C max (4 times)	96pcs	Pass
TCT	-55°C/125°C; 1000cycles	32pcs	Pass
uHAST	110°C/85% RH; 500hrs	32pcs	Pass
THB	85°C/85% RH, Vdd max; 1000hrs	32pcs	Pass
HTS	150°C; 1000hrs	32pcs	Pass

For questions regarding this notice, e-mails can be sent to the regional contacts shown below or your local Field Sales Representative.

Location	E-Mail
DLP® Products	Dlp-pcn-team@list.ti.com
USA	PCNAmericasContact@list.ti.com
Europe	PCNEuropeContact@list.ti.com
Asia Pacific	PCNAsiaContact@list.ti.com
Japan	PCNJapanContact@list.ti.com